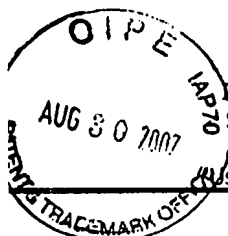


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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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APPLICANTS
Thilo Weitzel

FILING DATE
January 18, 2005

GROUP ART UNIT
2877

U.S. PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
/SAT/		04-055726	2/92	Japan				

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

/SAT/			GIOVANNINI et al., "Interferometric configuration based on a grating Interferometer for the measurement of the phase between TE and TM polarizations after diffraction by gratings," Optical Letters, Vol. 20, No. 21, Nov. 1995, Pp. 2255-2257.
/SAT/			GIULIANI et al., "Spectral characteristics of laser cavities employing multipass grating interferometers as output couplers," J. Opt. Soc. Am.B., Vol. 4, No. 11, Nov. 1987, Pp. 1781-1789.

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